

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 7,413,609 B2  
APPLICATION NO. : 10/575481  
DATED : August 19, 2008  
INVENTOR(S) : Toshirou Umeki

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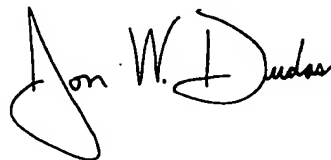
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 10, Line 23, cancel the text beginning with "1. A semiconductor" and ending "with a collar" and insert the following claim:

--A semiconductor single crystal manufacturing apparatus, comprising a chamber disposed in a furnace and having a crucible in which a melt is charged, a heater for heating the crucible, and a wire within the chamber, wherein: at least a region of the wire, which is exposed to a high temperature by radiant heat from a heater that heats the crucible, is covered with a collar.--

Signed and Sealed this

Seventh Day of October, 2008

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a cursive "Dudas".

JON W. DUDAS  
*Director of the United States Patent and Trademark Office*